



## Ultrasensitive and Broadband MoS<sub>2</sub> Photodetector Driven by Ferroelectrics

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During the past ten years, because of the unique properties of single layer graphene, 2D materials draw more and more attention for their potential applications in future nanoscale electronic/optoelectronic devices. [1–13] Molybdenum disulfide (MoS<sub>2</sub>), consisting of layered S–Mo–S units structures bonded by van der Waals forces, has also been widely studied in recent years. [2,8,9,14–17] MoS<sub>2</sub> is a typical semiconductor with a band gap range from 1.2 to 1.8 eV as the thickness decreases from bulk to monolayer. [18–20] Field effect transistors based on monolayer or multilayer MoS<sub>2</sub> possess high current ON/OFF ratios of up to  $10^7$ – $10^8$ . [21–23] Owing to these special features, ultrathin MoS<sub>2</sub> becomes a promising candidate material for future electronic applications.

For transistors based on 2D graphene and  $MoS_2$ , traditional dielectric materials, such as  $SiO_2$ ,  $HfO_2$ , and  $Al_2O_3$ , possessing linear dielectric response to an electric field, are usually selected as gate dielectrics. [1,8,14,16,17] Many interesting and meaningful physical properties have been discovered using these materials. Among these, the optoelectronic properties of a field effect transistor, especially the  $MoS_2$  photodetector (sometimes named a phototransistor), have attracted intensive attention. [14–17] For these photodetectors, the photoresponsivity is relatively low, with the first monolayer  $MoS_2$  phototransistors

exhibiting a photoresponsivity of 7.5 mA W<sup>-1</sup>.<sup>[15]</sup> The specific detectivity D\* for a photodetector, a figure of merit used to characterize performance, is a metric of detector sensitivity. Among these photodetectors, the detectivity is unfavorable for practical applications. Additionally, for these traditional photodetectors, additional gate bias  $(V_{g})$  and a large drain-source bias  $(V_{sd})$  are essential for obtaining high sensitivity. Such Vg may induce a leakage between source and gate, and the large  $V_{sd}$  leads to a significant increase in dark current between the source and drain, as well as a self-heating effect in the channel. These effects will not only cause a large power dissipation but will also seriously degrade the performance, such as low sensitivity.<sup>[24,25]</sup> In recent years, poly(vinylidene fluoride-trifluoroethylene) (P(VDF-TrFE)) ferroelectric polymer films and (lithium niobate) LiNbO3 ferroelectric crystal has been used in nano electronic devices, such as nonvolatile memories. [26-31] In these devices, the function of the ferroelectric film is to tune the transport properties of the channel. However, ferroelectric materials combined with the photoelectric 2D materials have never been used for optoelectronic devices, for example, photodetectors.

In this work, the MoS<sub>2</sub> transistor with a ferroelectric gate is used as a photodetector, wherein the few-layer MoS2 serves as the photosensitive semiconducting channel while the remnant polarization of P(VDF-TrFE) is employed to depress the dark current of the MoS<sub>2</sub> semiconducting channel. The stable remnant polarization can provide an ultrahigh local electrostatic field (≈10<sup>9</sup> V m<sup>-1</sup> within a several nanometer scale) in the semiconductor channel which is larger than that produced by gate bias in traditional field effect transistors.[15-17] With such an ultrahigh electrostatic field, the few-layer MoS2 channel is maintained in a fully depleted state, significantly increasing the sensitivity of the detector even at ZERO gate voltage. Based on these special properties, a photodetector with high detectivity  $\approx$ 2.2 × 10<sup>12</sup> Jones and photoresponsivity up to 2570 A W<sup>-1</sup> has been achieved. In addition, for the first time the photoresponse wavelengths of the ferroelectric polarization gating MoS<sub>2</sub> photodetector are extended from the visible to the near-infrared (0.85-1.55 µm).

A few-layer MoS<sub>2</sub> on a degenerately doped silicon substrate covered with a 285 nm thick silicon oxide was prepared using the Scotch tape-based mechanical exfoliation method. [2.8] The molecular configurations of MoS<sub>2</sub> are shown in Figure 1a. The source and drain chromium (Cr, 5 nm)/gold (Au, 50 nm) electrodes were prepared using the lift-off method. The following step was coating the P(VDF-TrFE) (70:30 in mol%) film as the top gate. The molecular configurations of P(VDF-TrFE)

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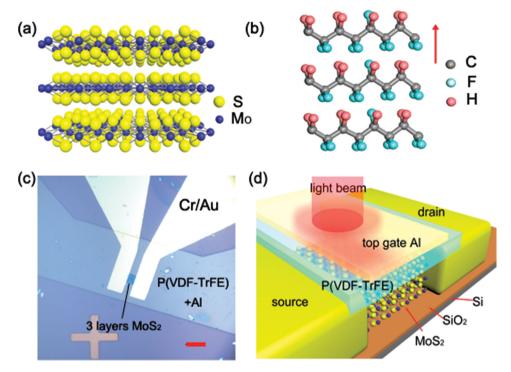


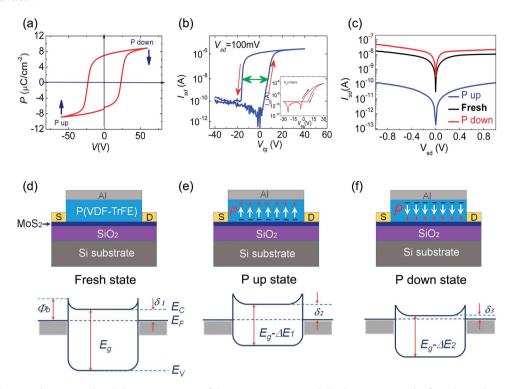
Figure 1. Fabrication and structure of few-layer  $MoS_2$  photodetector. a) Schematic structure of triple-layer  $MoS_2$ . b) Schematic structure of P(VDF-TrFE) ferroelectric polymer. The polarization direction of the polymer is pointed out by arrow. c) Optical image of the whole device. The device is comprised of triple-layer  $MoS_2$  with Cr/Au contract, 300 nm P(VDF-TrFE) ferroelectric polymer and semitransparent aluminum top electrode. Scale bar, 10  $\mu$ m. d) 3D schematic view of the triple-layer  $MoS_2$  photodetector with monochromatic light beam.

are shown in Figure 1b. The ferroelectric dipole direction in the P(VDF-TrFE) chain is also shown in Figure 1b. Then the ultrathin semitransparent aluminum ( $\approx$ 15 nm) electrodes were deposited. The thickness of the few-layer MoS<sub>2</sub> was confirmed by the Raman spectrum (Figure S1, Supporting Information). The peak locations of  $E_{2g}^1$  and  $A_{1g}$  are 381.32 and 404.65 cm<sup>-1</sup>, respectively, and the frequency difference between  $E_{2g}^1$  and  $A_{1g}$  vibration modes is 23.27 cm<sup>-1</sup>. These data correspond to a film thickness of 2.1 nm for the triple-layer MoS<sub>2</sub>. [18,19] The optical image of the whole device based on MoS<sub>2</sub> and P(VDF-TrFE) is shown in Figure 1c. The 3D device structure schematic view of the ferroelectric polarization gating MoS<sub>2</sub> photodetector with laser beam illumination is shown in Figure 1d.

Then, the ferroelectric properties of P(VDF-TrFE) copolymer films have been characterized. A typical hysteresis loop for a P(VDF-TrFE) capacitor is shown in Figure 2a. The thickness of the P(VDF-TrFE) layer is 300 nm. The coercive voltage is  $\approx$ 22.5 V and the remnant polarization value is 7 µC cm<sup>-2</sup>. The polarization switching voltage can be reduced to ≈5 V with decreasing thickness of the ferroelectric layer.[27] Next, the transfer curves  $I_{\rm sd} {-} V_{\rm tg}$  (drain-source current  $I_{\rm sd}$  as a function of top gate voltage V<sub>tg</sub>) of the MoS<sub>2</sub> transistor with ferroelectric polymer were investigated at room temperature (shown in Figure 2b). The large memory window ( $\approx$ 25 V) in I-V curves between the voltage rise and decrease is related to the ferroelectric polarization switching process. It is more obvious by comparing this curve with the one obtained with the SiO2 back gate (the inset of Figure 2b). A mobility of  $\mu \approx 86.5 \text{ cm}^2 \text{ V}^{-1} \text{ s}^{-1}$  is calculated from the polymer gated transfer curve using the method in ref. [8]. Briefly, the mobility was calculated by the expression of  $\mu = (dI_{\rm ds}/dV_{\rm bg}) \times (L/(W \cdot \varepsilon_0 \varepsilon_{\rm r}/d \cdot V_{\rm ds}))$ , where  $L = 5.0 \ \mu \rm m$  is the channel length,  $W = 6.2 \mu m$  is the channel width,  $\varepsilon_r = 10$  is the dielectric constant of P(VDF-TrFE), d = 300 nm is the thickness of P(VDF-TrFE) films, and  $dI_{ds}/dV_{bg}$  is extracted from left side of the transfer curve in Figure 2b. The measured transfer characteristics exhibit a typical n-type channel FET, showing good agreement with that of a conventional transistor.[8] With the back gate, a mobility of  $\mu \approx 24.6 \text{ cm}^2 \text{ V}^{-1} \text{ s}^{-1}$  for the fewlayer MoS2 was obtained. The hysteresis behavior is related to the surrounding conditions or the charge transfer from neighboring adsorbates or charge injection into the trap sites on the substrate.[32] The difference in the mobility derived from top or back gates may be associated with the interface nature at the contacts. [33,34] Based on the ferroelectric polymer/MoS<sub>2</sub> structure, we can achieve three different states: P(VDF-TrFE) without polarization (named as the "fresh" state), polarization up state  $(P_{up})$ , and polarization down state  $(P_{down})$ . The  $P_{up}$  and  $P_{\text{down}}$  states are achieved by poling P(VDF-TrFE) with -40 V and +40 V. During the polarization switching process of ferroelectric polymer, the coercive field is strongly related to the applied voltage and frequency.[35] Additionally, as it is shown in Figure 2b, the MoS2 channel can be fully accumulation and depletion under ±40 V. A 40V pulse voltage with the pulse width of 2 s is chosen for poling the P(VDF-TrFE) film. The V<sub>sd</sub>-I<sub>sd</sub> characteristics (without additional gate voltage and light illumination) of these three states are shown in Figure 2c. In the  $P_{up}$  state,  $I_{sd}$  is the lowest compared to that of the other two states. This situation means that the depleted state of carriers







**Figure 2.** Ferroelectric polarization related electric properties of the P(VDF-TrFE)/MoS<sub>2</sub> hybrid structure. a) The ferroelectric hysteresis loop 300 nm P(VDF-TrFE) film capacitor. It is measured using Sawyer-Tower circuit at 1 Hz applied voltage frequency. b) The transfer curves of triple-layer MoS<sub>2</sub> channel with P(VDF-TrFE) ferroelectric polymer gate on dark state at room temperature. The transfer characteristics of triple-layer MoS<sub>2</sub> with SiO<sub>2</sub> back gate are shown in the inset. c) The  $V_{sd}$ - $I_{sd}$  characteristics (at ZERO gate voltage) with three states of ferroelectric layer. The three states are: fresh state (ferroelectric layer without polarization), polarization up (" $P_{up}$ ," polarized by a pulse  $V_g$  of –40 V), and polarization down (" $P_{down}$ ," polarized by a pulse  $V_g$  of –40 V) states, respectively. d–f) The cross section structures of the device and equilibrium energy band diagrams of three different ferroelectric polarization states with  $V_{sd} = 0$  V. For the band diagrams of different states, small Schottky barriers at the source and drain electrodes are considered.  $E_F$ ,  $E_C$ ,  $E_V$ ,  $\Phi_B$ , and  $E_g$  are the Fermi level energy, minimum conduction band energy, maximum valence band energy, Schottky barrier height, and band gap of MoS<sub>2</sub>, respectively. δ is the height from bottom of conduction band to the Fermi level. δ<sub>1</sub>, δ<sub>2</sub>, and δ<sub>3</sub> are related to the three states.

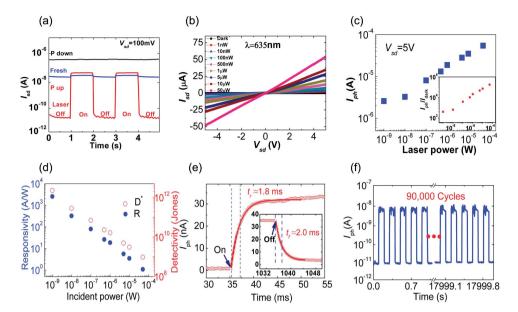
in the  $MoS_2$  channel is caused by the electrostatic field derived from the remnant polarization of P(VDF-TrFE). On the other hand, the  $P_{\rm down}$  state corresponds to the accumulated states of carriers in the  $MoS_2$  channel. The cross sections of the device structures and equilibrium band diagrams at the different states are shown in Figure 2d–f. For a photodetector, the  $V_{\rm sd}$ –  $I_{\rm sd}$  represents the dark current level without light illumination.

Next, the photoresponse of the MoS<sub>2</sub> photodetector was measured at a ZERO gate voltage. The photo switching properties (under  $V_{sd} = 100 \text{ mV}$ ) at a wavelength of 635 nm with the three states described above are shown in Figure 3a. In the fresh state, the signal-to-noise-ratio, photoresponse current ( $I_{ph}$ ) to dark current ( $I_{dark}$ ) is very small. In the  $P_{up}$  state, a signal-to-noise-ratio of 10<sup>3</sup> is obtained, as can be seen from the photoresponse to pulsed laser illumination curves. In the  $P_{\text{down}}$  state,  $I_{\text{ph}}$  cannot be distinguished from the large  $I_{\text{dark}}$ as the large thermionic and drift/diffusion currents dominate channel current. The results indicate that the electrostatic field produced by the surface charge at the domain surface of P(VDF-TrFE) is strong enough to cause total depletion/accumulation of carriers in the MoS2 semiconducting channel. The domain direction in the ferroelectric material of a charge insufficiently compensated system can be altered by a depolarization field, which leads to the random distribution of ferroelectric domains and, eventually, to the malfunction of the

device. (Indeed, before fabricating the ferroelectric layer, we have characterized the photoresponse properties of back gated MoS<sub>2</sub> photodetector, as shown in Figure S2 (Supporting Information). The performance of the traditional back-gate photodetector is very poor compared to the MoS2 photodetector with ferroelectric polarization gating.) The photoresponse behavior of our photodetector can be explained by the energy band diagrams as shown in Figure 2d-f. The light illumination results in light absorption and excitation of electron-hole pairs, which can be extracted by applying a drain-source bias. In the  $P_{\text{down}}$  and fresh states, both photogenerated current and thermionic/tunneling currents contribute device currents as described in ref. [14]. While in  $P_{up}$  state, the photogenerated current dominants the channel current, resulting in a high-efficient photocurrent extraction and increased photoresponse, as shown in Figure 3a. Meanwhile, the optothermal effect,[36] which is related to the pyroelectric properties of ferroelectrics, has been excluded in our photodetector. There is no photoresponse for the wavelength of 2 µm light illumination, as it is shown in Figure S10 (Supporting Information). For the following measurement, the ferroelectric polarization in P(VDF-TrFE) was preset at a  $P_{\rm up}$  state by a short bias pulse of 40 V on the top gate. The  $I_{\rm sd}$ - $V_{\rm sd}$  for different illumination powers at a wavelength of 635 nm is shown in Figure 3b. The  $I_{\rm sd}$ – $V_{\rm sd}$  curves, as shown in Figure 3b, are linear and symmetric.



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**Figure 3.** Photoresponse properties of the ferroelectric polarization gating triple-layer MoS<sub>2</sub> photodetector. a) Photoswitching behavior of ferroelectric polarization gating triple-layer MoS<sub>2</sub> photodetector at three states ( $\lambda$  = 635 nm,  $V_{sd}$  = 100 mV, P = 100 nW). b) Drain–source characteristic of the photodetector in the dark and under different illuminating light powers (1 nW to 50 μW). c) Dependence of photocurrent on illumination powers. The inset is the ratio of photoresponse current to dark current under different illumination powers. d) Photoresponsivity of the MoS<sub>2</sub> phototransistor, showing high sensitivity. The device exhibits a photoresponsivity of 2570 A W<sup>-1</sup> for an laser power of 1 nW, and the detectivity is up to ≈2.2 × 10<sup>12</sup> Jones. e) The rise and fall of the photocurrent and the fitted data using exponential functions (recorded by  $V_{sd}$  = 100 mV and P = 100 nW). f) Photocurrent response during 90 000 cycles of operation at  $V_{sd}$  = 100 mV and P = 100 nW. The device shows an endurable photoresponse. All of the data are achieved on the same device in the  $P_{up}$  state. The difference of  $I_{ph}$  in Figure 3a,e,f may be related to the test environment. In addition, the laser power could slightly fluctuate with the humidity of environment.

Figure 3c shows the laser power dependence of  $I_{\rm ph}$  of the device with  $V_{\rm sd} = 5$  V. The inset in Figure 3c is the ratio of  $I_{\rm ph}$  to  $I_{\rm dark}$ for light on and light off (dark states) at different illumination powers. It can be seen that the device is very sensitive to illumination power. The responsivity (R) of the photodetector is up to 2570 A W<sup>-1</sup> and the detectivity is about  $\approx 2.2 \times 10^{12}$  Jones (under low illumination power 1 nW). The data are extracted from Figure 3b, where  $V_{\rm sd}=5$  V and P=1 nW, given by  $R = I_{\rm ph}/P$ , where  $I_{\rm ph}$  is the photo current in a detector and Pis the illumination power. $^{[37,38]}$  The value of R (2570 A W<sup>-1</sup>) is larger than previously recorded result ≈880 A  $\mathrm{W}^{-1}$  (150 pW,  $V_{\mathrm{sd}}$ = 8 V, and  $V_g = -70$  V). [8] In addition, the detectivity, assuming that noise from dark current is the major factor, it is given by  $D^* = RA^{1/2}/(2eI_{\text{dark}})^{1/2}$ , where *R* is the responsivity, *A* is the area of the detector, e is the unit charge, and  $I_{\rm dark}$  is the dark current.<sup>[39]</sup> The maximum detectivity ≈2.2 × 10<sup>12</sup> Jones has been achieved, which is higher than that of detectors based on 2D materials. As shown in Figure 3d, the high detectivity and responsivity decrease dramatically with the increasing signal power. This decreasing can be explained that trap states present either in MoS2 or at the interface between MoS2 and P(VDF-TrFE) layer.[40] Note that, if a highly transparent electrode (for example graphene, Ag nanowire) is chosen, a higher responsivity can be expected. Currently, the transmittance of the available semitransparent Al electrode is only 30% for our device. It suggests that a flawless device fabrication is needed for superior performance in the future.

In addition to the superior sensitivity and good photoresponsivity, we conducted time-resolved photoresponse experiments by periodically turning the illuminating laser on and off at a

frequency of 0.5 Hz and recording the response signal with a high speed oscilloscope (as shown in Figure S3 in the Supporting Information). Figure 3e shows a complete on/off cycle in which the photocurrent exhibits rapid rise/fall and reaches a steady saturation. The rising and falling edges of the response current are perfectly fitted by a single exponential function. The rise  $(\tau_r)$  and decay  $(\tau_f)$  times of the photocurrent, are  $\approx 1.8$ ms and ≈2 ms, respectively, which is relatively fast for stateof-the-art 2D photoconductive photodetectors. In our case, the improvement of response time may result from the interface of P(VDF-TrFE) and MoS2, the surface trap state of MoS2 may be encapsulated or passivated by the fluorine or hydrogen atoms from polarized P(VDF-TrFE). Furthermore, the signals recorded by the oscilloscope remain nearly unchanged after 90 000 cycles of operation (as shown in Figure 3f), pointing to the excellent stability and reliability of the photodetectors. The stability of the photo-switching behavior is related to the ferroelectric polarization stability of the P(VDF-TrFE) top gate<sup>[41,42]</sup> and the reliability of the P(VDF-TrFE)-passivated MoS2 channel.

All the prominent properties of our photodetector benefit from the ferroelectric-polarization-induced ultrahigh electrostatic field of the P(VDF-TrFE). The local electric field at the interface between P(VDF-TrFE) and MoS<sub>2</sub> layers can be estimated from  $\sigma = \varepsilon \varepsilon_0 E$ , where  $\sigma$  is the charge density at the surface of P(VDF-TrFE) film, which is related to the remnant polarization ( $P_r$ ) of the ferroelectric materials,<sup>[27]</sup>  $\varepsilon$  is the dielectric constant of material (the dielectric constant of MoS<sub>2</sub> is  $\approx 4-6$ ,<sup>[43,44]</sup>  $\varepsilon_0$  is the vacuum permittivity, E is the electric field strength, and  $P_r$  is  $\approx 7.0~\mu C$  cm<sup>-2</sup> calibrated from Figure 2a. The calculated electric field applied to the triple-layer MoS<sub>2</sub> is

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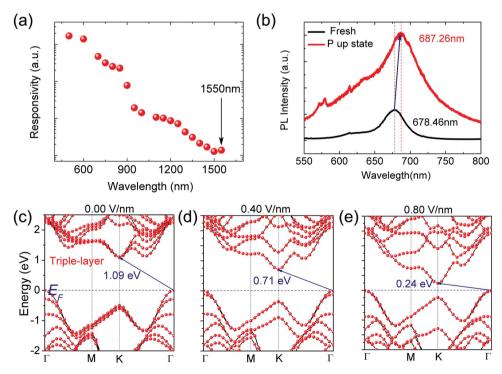
about  $0.5\times10^9$  V m<sup>-1</sup>. It is very difficult to obtain such an ultrahigh electric field for conventional FETs as described by several research groups. [27,45–47]

The typical photoresponse spectra of an MoS2 photodetector is from visible to near-infrared (0.85 µm) as the band gap of MoS<sub>2</sub> ranges from 1.2 eV to 1.8 eV. As reported by Oriol Lopez-Sanchez et al., photoresponse is negligible at wavelengths longer than 680 nm (corresponding to one photon energy 1.8 eV) for monolayer MoS<sub>2</sub>. [14] For triple-layer MoS<sub>2</sub>, the broad absorption tail corresponding to the indirect band transition extends to near 0.85 µm, which is in good agreement with the theoretical prediction.<sup>[17]</sup> In this work, we also characterized the photoresponse properties of fresh state MoS2 photodetector, where the response wavelength ends at ≈900 nm (as shown in Figure S4 in the Supporting Information). A wider spectral response for a photodetector is important and meaningful. Therefore, the response of the detector to light with long wavelength was investigated. The photoresponse of the detector to laser illumination with different wavelengths is shown in Figure 4a. Surprisingly, it is found that there is still appreciable optical current response to light with wavelength up to 1.55 µm. For the first time, our work broadens the detection of an MoS<sub>2</sub> photodetector from 0.85 to 1.55 µm.

To confirm the effect of the electric field polarization on the band structure of few-layer MoS<sub>2</sub>, we carried out microphotoluminescence (PL) measurements on the fresh (ferroelectric domain random) and poled (domain aligned) samples (in Figure 4b). The PL emission for the pole sample is redshifted compared to that of the fresh sample, In addition, the PL emission intensity is also increased after the cover of poled

P(VDF-TrFE). This PL emission intensity increasing may be related to the electric field modifying the band structure of the MoS<sub>2</sub> and in turn increasing the density of states of the carriers. With the increase in the carrier population, the radiative recombination of carriers increases, which leads to an increase in PL intensity.<sup>[48,49]</sup> Similarly, the band structure of MoS<sub>2</sub> can be tuned by the external strain and confirmed by PL spectrum.<sup>[48–51]</sup> Note that an optical band gap measured by PL is different from the band gap of electron transport due to the exciton binding energy. It has been theoretically predicted that the energy gap of the bilayer MoS<sub>2</sub> can be tuned by the external electric field.<sup>[52,53]</sup> The change in the band gap in triple-layer MoS2 under external electric fields applied perpendicular to the layers was also calculated using the density functional theory. The band structure of triple-layer MoS2 as a function of applied different external electric field is shown in Figure 4c-e. For example, a 0.40 V nm<sup>-1</sup> of electric field strength can reduce the band gap from 1.09 to 0.71 eV (details of the calculation are shown in the Supporting Information). The indirect band gap is reduced with an increase of the applied electric field, and the relationship between  $E_{\sigma}$  and electric field is linear (as shown in Figure S6 in the Supporting Information). Additionally, the electrostatic fields from the ferroelectrics may induce defects in MoS2. Such defects in transition metal dichalcogenides could also be one of the possible reasons for the PL spectrum variation.<sup>[54]</sup>

Further studies are needed to clarify the fundamental physics principles of the ferroelectric polarization tuning for the band gap of few-layer MoS<sub>2</sub>. Nevertheless, the ferroelectric/MoS<sub>2</sub> hybrid structure photodetector shows an outstanding performance for detection. Similar electric and photoresponse



**Figure 4.** Infrared photoresponse of ferroelectric polarization gating few-layer  $MoS_2$  photodetector beyond its intrinsic band gap. a) Photoresponsitivity of a similar polarization-gating triple layer  $MoS_2$  photodetector as a function of light wavelength from 500 nm to 1550 nm at  $V_{sd} = 1$  V,  $P = 100 \mu W$  under  $P_{up}$  state. b) Comparison photoluminescence spectrum of fresh and polarization gating triple-layer  $MoS_2$ . c–e) The band structures evolution of triple-layer  $MoS_2$  under different external electric field (0.0, 0.4, and 0.8 V nm<sup>-1</sup>) by first-principles DFT calculations.

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properties have also been achieved on the same structure with four-layer  $MoS_2$  photodetector (as shown in Figures S7 and S8 in the Supporting Information). Our photodetector shows a high sensitivity under weak illumination, such as fluorescent lamp, demonstrating that the few-layer  $MoS_2$  is very promising for a visible to near-infrared digital camera.

In summary, we have fabricated a ferroelectric polymer film gated triple-layer MoS2. The MoS2 device exhibited outstanding photodetection capabilities compared to traditional MoS2 FET photodetectors. The device exhibits a maximum attainable photoresponsivity of 2570 A W<sup>-1</sup>, and high detectivity of  $2.2 \times 10^{12}$ Jones, which are record values compared to the previous reports on MoS2 and other 2D material photodetector. In addition, the broad spectral regions detection, stable and fast photoresponse of the detector are also superior to recently reported MoS<sub>2</sub> photodetectors. The infrared (0.85-1.55 µm) photoresponse of the ferroelectric polarization gating MoS<sub>2</sub> photodetector suggests that such an MoS<sub>2</sub> photodetector is very promising for use in optical communications. The energy gap engineering of a 2D material system combined with an ultrahigh ferroelectricpolarization-induced electrostatic field is an attractive research area for next-generation high performance 2D electronic/optoelectronic devices. There are many fruitful and fundamental physics issues in ferroelectric/photoelectric 2D material hybrid systems to be explored in future studies.

All measurements were performed under ambient conditions. Triple layers of MoS2 were exfoliated from commercially available crystals of molybdenite (SPI Supplies brand Moly Disulfide) using the Scotch-tape micromechanical cleavage technique pioneered for the production of graphene. Triple layers of MoS<sub>2</sub> were deposited on a ≈285 nm thick SiO<sub>2</sub> dielectric layer on top of a highly-doped p-type Si wafer (resistivity  $< 5 \times 10^{-3} \Omega$  cm). Electrical contacts were patterned on top of MoS2 flakes using a conventional lift-off technique. Cr (5 nm) and Au (50 nm) electrodes were deposited by thermal evaporation at room temperature. The device was then annealed at 200 °C in a vacuum tube furnace for 2 h (100 sccm Ar) to remove resist residue and to decrease contact resistance. The P(VDF-TrFE) (70:30 mol%) ferroelectric polymer power was dissolved in the diethyl carbonate with 2.5%wt firstly. Then the P(VDF-TrFE) films were prepared by spin coating on the top of the MoS<sub>2</sub>. After that, the P(VDF-TrFE) films were annealed at 135 °C for four hours for improving their crystallinity. Finally, ultrathin aluminum films were deposited by thermal evaporation and patterned by photolithography as the top gate semitransparent electrodes.

We performed the electrical and optoelectrical characterization of our device at room temperature using a Lake Shore probe station and Agilent semiconductor parameter analyzer.

In this work, electrical measurements were carried out using an Agilent B2902A, Signal Recovery current preamplifier, lock-in amplifier Signal Recovery 7270 and a current preamplifier Signal Recovery 5182 on the Lake Shore probe station. The photoresponse to laser excitation used a focused  $\lambda=500-1550$  nm laser beam. A monochrometer was used for wavelength-dependent measurements of the photocurrent. The Raman spectra and PL spectra were acquired by the Lab Ram HR800 from HORIBA (excitation wavelength 532 nm, power 2 mW, spot size 2–3  $\mu$ m). Time-resolved photoresponse were achieved by the high-speed Tektronix MDO3014 Oscilloscope.

## **Supporting Information**

Supporting Information is available from the Wiley Online Library or from the author.

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